IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

ln re a	pplication of: Yoshihiro HAMAKAWA et al	l:					
	• •)	Examiner: A. Diamono				
Serial	No: 09/988,998 (11/21/01)	:					
)	Group Art Unit:1753				
Filed:	Concurrently Herewith)					
	•	:	-				
For:	Photovoltaic Apparatus and Mass-Producing						
	Apparatus for Mass-Producing Spherical						
	Semiconductor Particles)					

COMMISSIONER OF PATENTS P.O. Box 1450 Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Sir:

Pursuant to Rule 37 C.F.R. §1.51(b), §1.56, §1.97, and §1.98, this Information Disclosure Statement is submitted in the above-identified patent application. A listing of documents to be published on the face of any patent granted from this application is submitted herewith on Form PTO-1449. Any other documents or information submitted for consideration by the Examiner are listed in this paper. A copy of each U.S. and foreign patent, or each publication or portion thereof listed or herein identified is submitted herewith, except that a copy of any U.S. patent application identified herein or any patent, publication or other information listed herein cited or submitted in a prior application relied upon for an earlier filing date under 35 U.S.C. §120 and identified below, is not submitted herewith.

ADDITIONAL DOCUMENTS OR INFORMATION NOT LISTED ON ACCOMPANYING FORM PTO-1449 SUBMITTED FOR CONSIDERATION

Notification of Reasons for Refusal dated April 30, 2003, issued to corresponding basic Japanese Patent Application No. 2000-358229

CERTIFICATION

This Information Disclosure Statement is submitted within three months of (i) the filing date of the above-identified U.S. National Patent application, or (ii) the date of entry into the U.S. National Stage of the above-identified International Application, or (iii) the date of entry into the U.S. National Stage of the International Application that has been assigned the above-identified U.S. Patent application number, whichever applies.

The Examiner is requested to acknowledge consideration of the information provided in this paper in accordance with prescribed procedures.

Please charge any additional fees or credit any overpayments in connection with this paper to Deposit Account No. 02-0200.

Respectfully submitted,

Benjamia E. Urcia

Registration No. 33,805

Date: June 27, 2003 BACON & THOMAS, PLLC 625 Slaters Lane, 4th Floor Alexandria, Virginia 22314 Telephone: (703) 683-0500

B/O Form PTO-1449		Atty. Docket Number HAMA3002/BEU		Serial Number 09/988,998					
	partment of Commerce and Trademark Office	Applicant Yoshihiro HAN		I		<u> </u>			
Information Disclosure Statement by Applicant				Group	Group 1753				
		U.S. Pat	ent Documents						
xaminer Initial	Document Number	Date	Patentee/Applicant		Class	Subclass	Filing Date if Appropriate		
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		Foreign P	atent Documents						
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Oth	er Documents (Including	g Author, Title,	, Date, Pertinent Page	s, Plac	e of Pu	blication,	Etc.)		
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EXAMINER: Initial if citation is considered, whether or not citation is in conformance with MPEP 609; Draw a line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

Date Considered

Examiner